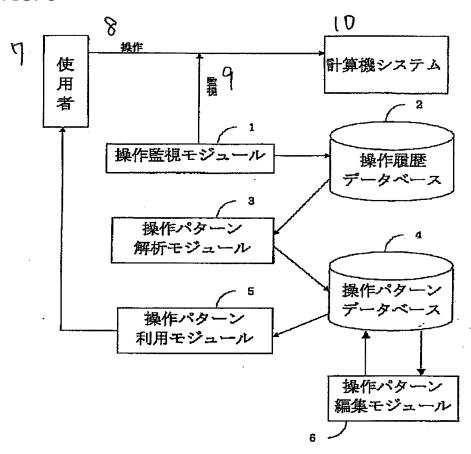
Japanese Unexamined Patent Application Publication No. 2002-7020

DRAWINGS

FIG. 5



- 1: Operation-monitoring module
- 2: Operation-history database
- 3: Operation-pattern-analyzing module
- 4: Operation-pattern database
- 5: Operation-pattern-using module
- 6: Operation-pattern-editing module
- 7: User
- 8: Operation
- 9: Monitoring
- 10: Computing system